

United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

DATE MAILED: 02/08/2005

APPLICATION N	O. I	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
09/943,758		09/04/2001	Vadim Y. Banine	P 282980 P-0202.011-US	8495	
909	7590	02/08/2005		EXAMINER		
		ΓHROP, LLP		NGUYEN	NGUYEN, LAM S	
P.O. BOX MCLEAN	10500 I, VA 221	02		ART UNIT	PAPER NUMBER	
				2853	2853	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)					
Office A - 4' Commence	09/943,758	BANINE ET AL.					
Office Action Summary	Examiner	Art Unit					
	LAM S NGUYEN	2853					
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply							
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely. - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication. - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).							
Status							
1) Responsive to communication(s) filed on 26 Oc	ctober 2004.						
2a) This action is FINAL . 2b)⊠ This	action is non-final.						
3) Since this application is in condition for allowar	3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is						
closed in accordance with the practice under E	x parte Quayle, 1935 C.D. 11, 45	53 O.G. 213.					
Disposition of Claims							
4) Claim(s) 1-17 is/are pending in the application.							
4a) Of the above claim(s) is/are withdrawn from consideration.							
5)⊠ Claim(s) <u>1-13 and 17</u> is/are allowed.							
6)⊠ Claim(s) <u>14 and 16</u> is/are rejected.							
7)⊠ Claim(s) <u>15</u> is/are objected to.							
8) Claim(s) are subject to restriction and/or	election requirement.						
Application Papers	·						
9) The specification is objected to by the Examine	r.						
10)⊠ The drawing(s) filed on <u>04 September 2001</u> is/are: a)⊠ accepted or b)□ objected to by the Examiner.							
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).							
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).							
11)☐ The oath or declaration is objected to by the Ex	aminer. Note the attached Office	Action or form PTO-152.					
Priority under 35 U.S.C. § 119							
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No. 09/942,953.							
3. Copies of the certified copies of the priority documents have been received in this National Stage							
application from the International Bureau (PCT Rule 17.2(a)).							
* See the attached detailed Office action for a list of the certified copies not received.							
Attachment(s) 1) Notice of References Cited (PTO-892)	A) T Intensions Summans	(PTO_413)					
2) Notice of Draftsperson's Patent Drawing Review (PTO-948) Paper No(s)/Mail Date							
3) X Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)	5) Notice of Informal F	Patent Application (PTO-152)					
Paper No(s)/Mail Date 10/26/2004.							

DETAILED ACTION

Page 2

Continued Examination Under 37 CFR 1.114

A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after allowance or after an Office action under *Ex Parte Quayle*, 25 USPQ 74, 453 O.G. 213 (Comm'r Pat. 1935). Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, prosecution in this application has been reopened pursuant to 37 CFR 1.114. Applicant's submission filed on 10/26/2004 has been entered.

The indicated allowability of claims 14 and 16 is withdrawn in view of the newly discovered reference(s) to Klebanoff et al. (US 6533952) submitted by the applicants.

Rejections based on the newly cited reference(s) follow.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.
- 1. Claims 14, 16 are rejected under 35 U.S.C. 102(e) as being anticipated by Klebanoff et al. (US 6533952).

Klebanoff et al. discloses a method of manufacturing a device using a lithographic projection apparatus comprising:

Page 3

projecting a patterned beam of radiation onto a target portion of a layer of radiation-sensitive material on a substrate (column 1, lines 30-40: The radiation is applied on the surface of the workpiece that is coated with a radiation-sensitive substance); and

supplying a gaseous alcohol (Abstract: A hydrocarbon gas is introduced into the environment of the surface; Column 4, lines 60-65: Hydrocarbon contains such polar functional groups such as alcohols) to a space in a radiation system of the lithographic projection apparatus, which space contains a mirror (FIG. 2, column 3, lines 50-53: Element 210 is a Si surface of a Mo/Si multilayer mirror).

Referring to claim 16: wherein the alcohol is ethanol (FIG. 4).

Allowable Subject Matter

2. Claims 1-13 and 17 are allowed and claim 15 is objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

Referring to claims 1, 10: The primary reasons for the indication of the allowability of the claims is the inclusions therein, in combination as currently claimed, of the limitation that al least one sensor selected from the group comprising a reflectively sensor to monitor a reflectivity of said mirror and a pressure sensor to monitor a background pressure in said space and a gas supply control, responsive to a signal from said at least one sensor to control said gas supply is neither disclosed nor taught by the cited prior art of record, alone or in combination.

Claims 2-9, 11-13, 17 are allowed because they depend directly/indirectly on claim 1 or 10.

Application/Control Number: 09/943,758 Page 4

Art Unit: 2853

Referring to claim 15: The primary reasons for the indication of the allowability of the claim is the inclusions therein, in combination as currently claimed, of the limitation that wherein the gaseous alcohol is supplied to said space at a pressure sufficient to achieve a thickness of said cap layer which does not increase substantially over time is neither disclosed nor taught by the cited prior art of record, alone or in combination.

Contact Information

Any inquiry concerning this communication or earlier communications from the examiner should be directed to LAM S NGUYEN whose telephone number is (571)272-2151. The examiner can normally be reached on 7:00AM - 3:30PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, STEPHEN D MEIER can be reached on (571)272-2149. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

LN February 1, 2005

HAI PHAM PRIMARY EXAMINER

Harchithan